



03500.011922.3

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)

MITSUTOSHI HASEGAWA)

Application No.: 09/966,595)

Filed: October 1, 2001)

For: METHOD OF MANUFACTURING)
ELECTRON-EMITTING DEVICE,)
ELECTRON SOURCE AND IMAGE-)
FORMING APPARATUS)

Examiner: M. Cleveland

Group Art Unit: 1762

March 11, 2002

#6/B
Hedley
3/28/02

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Commissioner For Patents
Washington, D.C. 20231

AMENDMENT

Sir:

This paper is filed in response to the Office Action of December 10, 2001
(Paper No. 5), which set forth a shortened statutory period for reply ending on Sunday,
March 10, 2002.

In response to that Office Action, please amend the above-identified
application as follows:

I hereby certify that this correspondence is being deposited with the
United States Postal Service as first-class mail in an envelope
addressed to: Commissioner for Patents, Washington, D.C. 20231
on March 11, 2002.

(Date of Deposit)

FRANK A. DeLUCIA

(Name of Attorney for Applicant)

Frank A. DeLucia
Signature

March 11, 2002

Date of Signature